

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Naofumi Nakamura et al.
Serial No. : 10/752,642
For : SEMICONDUCTOR DEVICE AND METHOD OF
FABRICATING THE SAME
Filing Date : January 7, 2004
Examiner : Jesse A. Fenty
Group Art Unit : 2815
Confirmation No. : 4109

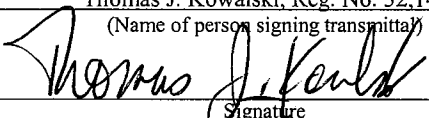
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(Name of person signing transmittal)


Signature

May 2, 2007

Date of Signature

**AMENDMENT AND PETITION FOR A TWO-MONTH EXTENSION OF TIME
SUBMITTED WITH A REQUEST FOR CONTINUED EXAMINATION**

MAIL STOP RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action mailed on November 2, 2006, having a three-month shortened statutory period for reply set to expire on February 2, 2007, and the Advisory Action mailed on March 27, 2007 in the above-captioned application, Applicants' attorneys submit herewith a Request for Continued Examination and respectfully request amendment of the above-identified application as follows.

Petition for Extension of Time is included on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims, which begins on page 4 of this paper.

Remarks/Arguments begin on page 8 of this paper.